

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	501126	capacitor\$1	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:46
L2	1489398	dielectric or insulat\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:46
L3	832883	core	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:47
L4	3400883	(metal\$3 or tantalum)	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:47
L5	62292	anodic\$5 or anodization or anodiz\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:48
L6	522000	pad\$1	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:48
L7	28590	4 same 5	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:48
L8	7401	2 same 7	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:48
L9	242	1 and 3 and 8	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:49
L10	51	6 and 9	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:49

L11	191	9 not 10	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:49
L13	1088898	electrode\$1	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:52
L14	320658	(opposite or back) near5 (core or substrate\$1 or layer\$1 or film\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:55
L15	44628	6 same 13	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:56
L16	336	1 and (4 same 4) and 3 and 14 and 15	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:57
L17	325	16 not 9	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	ON	2005/07/25 09:57

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L1	117	(metal\$3 and capacitor\$1 and dielectric and (electrode\$1 or conductor\$1) and pad).clm.	US-PGPUB	OR	ON	2005/07/25 09:36